

L Number	Hits	Search Text	DB	Time stamp
37	4967	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) and (cathode electrode)	USPAT; US-PGPUB	2004/10/16 15:41
38	2454	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode)	USPAT; US-PGPUB	2004/10/16 15:41
51	25	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode)) and 156/\$.ccls.	USPAT; US-PGPUB	2004/10/16 15:46
52	1081	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode))	EPO; JPO; DERWENT	2004/10/16 15:46
53	15	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (thick near3 (dielectric insulat\$3))) same (cathode electrode))	EPO; JPO; DERWENT	2004/10/16 15:50
54	1	5047313.pn.	USPAT; US-PGPUB	2004/10/16 15:54
55	0	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3)	USPAT; US-PGPUB	2004/10/16 15:55
56	801	(multi\$layer\$3 with cathode) and (dielectric insulat\$3)	USPAT; US-PGPUB	2004/10/16 15:55
57	203	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3)	USPAT; US-PGPUB	2004/10/16 15:55
58	67	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3) and (313/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 15:59
59	7	(multi\$layer\$3 near3 cathode) and (thick near3 (dielectric insulat\$3 isolat\$3)) and (313/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 16:00
60	333	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (313/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 16:40
61	82	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (313/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 17:11
62	22	("3731131" "3998678" "4193013" "4345181" "4498952" "4551649" "4683399" "5019003" "5129850" "5138220" "5141460" "5180951" "5190796" "5199918" "5202571" "5227699" "5249340" "5252833" "5278475" "5371431" "5449970" "5451830").PN.	USPAT	2004/10/16 16:45
63	4	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	2004/10/16 17:08
64	46	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	2004/10/16 17:08
65	3	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (216/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 17:13
66	62	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) with pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/16 17:21
67	4	("3970887" "4513308" "5266530" "5358908").PN.	USPAT	2004/10/16 17:13
68	3584	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/16 17:22
69	88	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (216/\$.cccls.)	USPAT; US-PGPUB	2004/10/16 19:24
70	19	((dielectric insulat\$3 isolat\$3) with thick with pattern\$3) and (216/13,17,62,87,95.ccls.)	USPAT; US-PGPUB	2004/10/16 19:25
71	19	((dielectric insulat\$3 isolat\$3) with thick) and (216/62.ccls.)	USPAT; US-PGPUB	2004/10/16 19:26
72	151	((dielectric insulat\$3 isolat\$3)) and (216/62.ccls.)	USPAT; US-PGPUB	2004/10/16 19:26
73	91	((dielectric insulat\$3 isolat\$3)) and (cathode electrode conductor) and (216/62.ccls.)	USPAT; US-PGPUB	2004/10/16 19:33

-	1371	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 11:18
-	5	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:19
-	20	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 430/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:21
-	31	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 216/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:24
-	49	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 430/\$.ccls.) (((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 216/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 11:21
-	113	((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and 216/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:24
-	198	((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric) and (cathode electrode) and (216/\$.ccls. 430/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 11:24
-	128	(diffus\$3 with (pattern\$3 etch\$3) with (insulat\$3 dielectric) and (cathode electrode) and (216/\$.ccls. 430/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 11:50
-	42	(actinic near3 (radiat\$3)) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:51
-	42	(actinic near3 (radiat\$3)) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 11:51
-	2	(actinic near3 (radiat\$3)) and 445/\$.ccls.	USOCR	2004/07/20 11:51
-	13	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and 445/\$.ccls.	USPAT; US-PGPUB	2004/07/20 13:35
-	112	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 13:36
-	140	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/07/20 13:37
-	66	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls. 445/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 13:38
-	16	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (438/\$.ccls. 216/\$.ccls. 430/\$.ccls. 445/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 16:01
-	10	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (313/\$.ccls.) and (cathode electrode)	USPAT; US-PGPUB	2004/07/20 15:53
-	20	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (cathode electrode) and ((field electron) near3 (emitter source emission emitting emissive))	USPAT; US-PGPUB	2004/07/20 16:12
-	2	(actinic same (radiat\$3 irradiat\$3 expos\$3 develop\$4) same (dielectric insulat\$3)) and (cathode electrode) and ((field electron) near3 (emitter source emission emitting emissive))	EPO; JPO; DERWENT	2004/07/20 16:12
-	1	1998-532288.NRAN.	DERWENT	2004/07/20 16:12
-	249	((diffusion with pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting))	USPAT; US-PGPUB	2004/07/22 15:44
-	699	((diffusion same pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting))	USPAT; US-PGPUB	2004/07/22 15:44
-	0	(diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting) near3 (display device panel))	USPAT; US-PGPUB	2004/07/22 15:47
-	2	(diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emisison source emissive emitting))	USPAT; US-PGPUB	2004/07/22 15:47
-	62	((difus\$3 patern\$3 (diffus\$3 near3 pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:03
-	702	((difus\$3 patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:03

-	23	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and (445/\$.ccls. 313/\$.ccls. 430/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 14:20
-	1	5032216.pn.	USPAT; US-PGPUB	2004/10/08 14:15
-	4	5209814.pn. 5260163.pn. 5275689.pn. 5306756.pn.	USPAT; US-PGPUB	2004/10/08 14:16
-	455	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:36
-	7	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and 216/\$.ccls.	USPAT; US-PGPUB	2004/10/08 14:43
-	0	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and 524/\$.ccls.	USPAT; US-PGPUB	2004/10/08 14:42
-	1658	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) and (430/\$.ccls. 445/\$.ccls. 313/\$.ccls. 438/\$.ccls. 216/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 14:43
-	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:44
-	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:44
-	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 14:45
-	14	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	EPO; JPO; DERWENT	2004/10/08 14:58
-	22	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode)	EPO; JPO; DERWENT	2004/10/08 15:03
-	766	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode)	EPO; JPO; DERWENT	2004/10/08 15:03
-	763	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode)	EPO; JPO; DERWENT	2004/10/08 15:04
-	471	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (electrode cathode)	EPO; JPO; DERWENT	2004/10/08 15:05
-	6	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (cathode)	EPO; JPO; DERWENT	2004/10/08 15:07
-	228	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (cathode)	USPAT; US-PGPUB	2004/10/08 15:08
-	2	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) with paste with (insulat\$3 dielectric isolat\$3)) and (cathode)	USPAT; US-PGPUB	2004/10/08 15:53
-	3	("5032216" "5209814" "5275689").PN.	USPAT	2004/10/08 15:20
-	5	5385631.URPN.	USPAT	2004/10/08 15:21
-	4	("5032216" "5037723" "5136207" "5385631").PN.	USPAT	2004/10/08 15:22
-	5	5385631.URPN.	USPAT	2004/10/08 15:50
-	4	5635334.URPN.	USPAT	2004/10/08 15:50
-	4	("5032216" "5037723" "5136207" "5385631").PN.	USPAT	2004/10/08 15:51
-	13	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) with paste with (insulat\$3 dielectric isolat\$3)) and (cathode electrode)	USPAT; US-PGPUB	2004/10/08 15:54
-	74	(pattern\$3 with thick with (dielectric insulat\$3 isolat\$3)) and (cathode electrode) and (((electron field) near3 (source emitting emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 16:03
-	32	(pattern\$3 with (thick near3 (dielectric insulat\$3 isolat\$3))) and (cathode electrode) and (((electron field) near3 (source emitting emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 16:08
-	372	((thick near3 (dielectric insulat\$3 isolat\$3)) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 16:13

-	66	((thick near3 (dielectric insulat\$3 isolat\$3))) same (conventional known)) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 16:27
-	0	(thick\$dielectric same (conventional known)) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and (313/\$.ccls. 445/\$.ccls.)	USPAT; US-PGPUB	2004/10/08 16:28
-	0	(thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/16 16:00
-	0	(thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	2004/10/08 16:28
-	9	(thick near3 dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	2004/10/08 16:31
-	72	((thick near3 dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	USPAT; US-PGPUB	2004/10/08 16:32